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INF	ORMAT	ION DISCLOSUR	E STATEMENT	BY APPLICANT	In	ventors: Vlad	J. Novo Chung Fu	_
''Multi-Axis Micro-Electro-Mechanical Actuator'' Group Art							Unit: Unknown 267	
					Exa	aminer Name:	Unknown	
-	·					torney Docket -001	No.:	
			U.S. E	Patent Documents	3			
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing If Appropr	
ω.c.	AA	6,252,466 B1	06/26/01	J. Patrick Kawamura	331	25		
w.c	AB	6,097,859	08/01/00	Solgaard et al.	385	17		
			Foreign	Patent Documen	ts			
							Transla	tion
		Document Number	Date	Country	Class	Subclass	Yes	No
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